

Application/Control No.	Applicant(s)/Patent under Reexamination			
10/678,994	SHIMADA, HIROYUKI	KI		
Examiner	Art Unit	-		
Kin-Chan Chen	1765			

SEARCHED							
Class		Subclass	Date		Examiner		
438		706	6/14/05		K-cc		
		710					
		714					
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		720					
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		722					
		585					
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43	8	587	1/14	1/05	K-	- ( (	

INTERFERENCE SEARCHED							
Class	Subclass	Date	Examiner				
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SEARCH NOTES (INCLUDING SEARCH STRATEGY)					
	DATE	EXMR			
East Keyworksearch US pst, US psq-pul. Epo, Jpo, Denvent JBM-TOB.					
inventor rearch	5-14-05	K-LC			
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